

Application/Control No.	Applicant(s)/Patent under Reexamination
10/621,229	IBANEZ, JUAN JOSE LEGARDA
Examiner	Art Unit
Jennifer Kim	1617

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SEARCHED					
Class	Subclass	Date	Examiner		
514	218	4/14/2006	JMK 7		
514	220	4/14/2006	V JMK		
	uplated	9/26/06	7		
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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	SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR			
Inventor search	4/14/2006	JMK			
STN (registry; medicine); see attached search terms.	4/14/2006	JMK			
west vpdated	4/14/2006	J _{MK}			
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